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## (54) SUBSTRATE FOR DISPLAY DEVICE

### (57)Abstract:

PROBLEM TO BE SOLVED: To provide a substrate for a display device which is easily made lightweight and thin, resistant to a shock, superior in flatness and contact with an ITO electrode, easy to manufacture, and further has superior gas barrier property and high performance in a wide band application.

SOLUTION: The substrate for the display device has: a plastic film of  $\geq 70\%$  mean light transmittance in a wavelength region of 400 to 700 nm and  $\geq 100^\circ\text{C}$  glass dislocation point; and a gas barrier layer containing an inorganic laminar compound and a polymer. Preferably, the value of retardation at a wavelength of 632.8 nm is  $\leq 15$  nm and the inorganic laminar compound is synthetic mica.

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## LEGAL STATUS

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